



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the U.S. Patent Application of

TOKMULIN et al.

Examiner: Zervignon, R.

Serial No.: 08/860,763

Art Unit: 1763

Filing Date: September 9, 1998

Docket No.: P-9701 ISK

For: Device for Treating Planar Elements with a Plasma Jet

Mail Stop IDS
U.S. Patent Office
Commissioner of Patents, P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

SIR:

It is respectfully requested that the art listed on the attached PTO form 1449 be made of record in the U.S. patent application captioned above and be considered by the U.S. Patent Examiner in the above application and made of record therein by including same in the "References Cited" portion of any patent to issue from this application.

06/30/2003 HRL111 00000056 08860763

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180.00 DP

These documents are being brought to the Examiner's attention because they have been cited in an Official Action issued by the Japanese Patent Office on May 13, 2003, during its examination of the corresponding Japanese patent application. A copy of the Japanese Official Action, with a translation into English, is included herewith.

1. U.S. Patent No. 3,278,796 to Sachio Takei et al;
2. PCT Publication No. WO 92/21220 published November 26, 1992;
3. Japanese Patent Laid-Open No. S55-143175;
4. Japanese Patent Laid-Open No. H05-179428;
5. Japanese Utility Model Laid-Open No. H04-130187;
6. Japanese Patent Laid-Open No. H02-312356;
7. Japanese Patent Laid-Open No. H05-038569; and
8. Japanese Utility Model Laid-Open No. H05-033534.

No representation is made or intended that better art than that listed is not available, or that the order of information listed is significant, or that an independent search has been made by the applicant. It is respectfully requested that the Examiner consider this information under 37 CFR 1.104.

U.S. Patent Application of Tokmulin et al.
Serial No.: 08/860,763 – Art Unit: 1763

The Examiner's due consideration of this information is respectfully solicited.

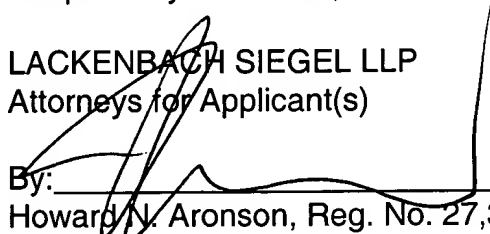
Applicant hereby petitions that any and all extensions of time of term necessary to render this response timely be granted. COSTS FOR SUCH EXTENSION(S) AND/OR ANY OTHER FEE DUE WITH THIS FEE DUE WITH THIS PAPER THAT ARE NOT FULLY COVERED BY AN ENCLOSED CHECK MAY BE CHARGED TO ACCOUNT #10-0100.

Date: June 25, 2003

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Respectfully submitted,

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By: 
Howard N. Aronson, Reg. No. 27,302

Certificate of Deposit by Mail

I hereby certify that this correspondence is being filed by depositing same in an envelope stamped first-class mail, addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, in a duly marked U.S. Postal Service drop box, with appropriate postage, on the following date:

Adrienne Shirley
Name of signee
Adrienne Shirley
Signature
June 25, 2003
Date